

03560.002998



2812  
8-22-02

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
YUKIKO IWASAKI ET AL.  
Application No.: 10/083,585  
Filed: February 27, 2002  
For: METHOD FOR  
MANUFACTURING A  
SEMICONDUCTOR FILM )  
Examiner: Not Yet Known  
Group Art Unit: 2812  
June 18, 2002

Commissioner for Patents  
Washington, D.C. 20231

RECEIVED  
JUN 24 2002  
TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT

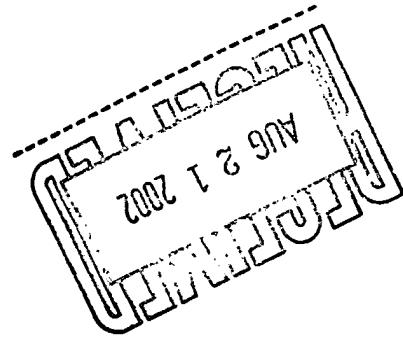
Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are enclosed.

The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/346,678	7/2/99	2815
09/592,559	6/12/00	2825

Copies of the cited Applications are also enclosed.

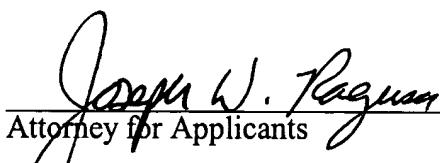


CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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Attorney for Applicants  
Registration No. 38,586

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